
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: KOEMTZOPOULOS

Attorney Docket No.:
LAM1P186/P1211

Application No.: Filed Herewith

Examiner: Unassigned

Filed: Herewith

Group: Unassigned

Title: DUAL DOPED POLYSILICON AND
SILICON GERMANIUM ETCH**CERTIFICATE OF EXPRESS MAILING**

I hereby certify that this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service on March 17, 2004 in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR §1.10, Mailing Label Number ER562285964US, addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signed: 

Sue Funchess

**INFORMATION DISCLOSURE STATEMENT
37 CFR §§1.56 AND 1.97(b)**

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure

Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0388 (Order No. LAM1P186).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP

A handwritten signature in black ink, appearing to read "Michael Lee", with a stylized flourish at the end.

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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No. LAMIP186/P1211	Application No.: Filed Herewith
	Applicant: KOEMTZOPOULOS et al.	
	Filing Date Herewith	Group Unassigned

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	1	5,269,879	12/14/93	Rhoades et al.	156	643	10/16/91
	2	5,658,425	08/19/97	Halman et al.	438	620	06/07/95
	3	5,846,443	12/08/98	Abraham	216	77	07/09/96
	4	5,908,320	06/01/99	Chu et al.	438	743	06/26/96
	5	6,004,884	12/21/99	Abraham	438	714	02/15/96
	6	6,013,582	01/11/00	Ionov et al.	438	738	12/08/97
	7	6,232,159B1	05/15/01	Uda	438	172	07/21/99
	8	6,291,356B1	09/18/01	Ionov et al.	438	710	05/24/99
	9	6,479,392B2	11/12/02	Yamazaki et al.	438	710	03/19/01
	10	6,537,918B2	03/25/03	Ionov et al.	438	710	07/31/01
	11	6,559,001B2	05/06/03	Athavale et al.	438	243	05/30/01
	12	6,576,507B1	06/10/03	Bandy et al.	438	234	11/14/00
	13	6,613,682B1	09/02/03	Jain et al.	438	706	10/21/99
	14	6,632,718B1	10/14/03	Grider et al.	438	305	06/24/99
	15	6,670,233B2	12/30/03	Athavale et al.	438	243	02/04/03
	16	2002/0016078A	02/07/02	Ionov et al.	438	710	07/31/01
	17	2002/0192900A	12/19/02	Athavale et al.	438	243	05/30/01
	18	2003/0143803A	07/31/03	Athavale et al.	438	243	02/04/03

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
	19	S63-13334	01/20/88	Japan	H01L	21/302	Yes	No
	20						Yes	No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	21	
	22	
Examiner	/Anita Alanko/	
	Date Considered	06/20/2008

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.